



**RESPONSE UNDER 37 C.F.R. § 1.116  
Expedited Examination Procedure  
Examining Group 2814**

PATENT  
ATTORNEY DOCKET NO.: 040894-5411-01

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Etsuyoshi KOBORI

Application No. 09/610,148

Filed: July 5, 2000

For: METHOD OF FABRICATING  
SEMICONDUCTOR DEVICE, AND  
SEMICONDUCTOR DEVICE

)  
) Confirmation No. 4659

)  
) Group Art Unit: 2814

)  
) Examiner: Anh D. Mai

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) **Mail Stop AF**

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Commissioner for Patents

U.S. Patent and Trademark Office

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Sir:

**RESPONSE UNDER 37 C.F.R. § 1.116  
AND REQUEST FOR RECONSIDERATION**

In response to the Final Office Action dated April 22, 2003 (Paper No. 13), the period for response to which has been extended through August 22, 2003 by the request for a one-month extension of time and fee filed concurrently herewith, and pursuant to 37 C.F.R. §1.116, reconsideration of the rejections set forth in the pending Office Action are respectfully requested.

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